

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re the Application of: **INOUE et al.**

Serial No.: **08/921,250**

Group Art Unit: **1763**

Filed: **August 29, 1997**

Examiner: **G.Goudreau**

For: **FABRICATION METHOD OF SEMICONDUCTOR DEVICE AND ABRASIVE LIQUID USED THEREIN**

RESPONSE TO ELECTION OF SPECIES REQUIREMENT

Commissioner for Patents
Washington, D.C. 20231

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Date: March 22, 2002

Sir:

This paper is submitted in response to the Official Action dated February 26, 2002.

In the Action, election of a species is required between Species 1, a second insulating film deposited onto a first insulating film wherein the surface of the first insulating film is ion implanted either before or after the second insulating film is deposited onto the first insulating film, and then cmp planarized (i.e. claims 3-14, 16, 20, 22-27 and 31); and Species 2, the surface of a first insulating film ion implanted followed by being cmp planarized (i.e. claims 17-19).

Applicants hereby elect the subject matter of Species 1. It is respectfully submitted that claims 3-14, 16, 20, 22-27 and 31 read on the elected species.

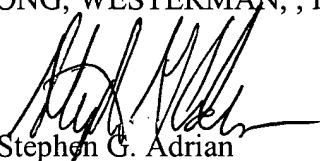
This election is made without traverse, it being understood that the Examiner will consider additional species upon allowance of a generic claim.

In the event that this paper is not timely filed, applicants hereby petition for an appropriate extension of time. The fee for any such extension may be charged to our Deposit Account No. 01-2340.

In the event any additional fees are required in connection with this response, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

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